

PATENT Attorney Docket No.: 16869P-041800US

Client Ref. No.: 210100244US1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

AKIRA HAMAMATSU et al.

Application No.: 10/082,593

Filed: February 22, 2002

For: SEMICONDUCTOR DEVICE

INSPECTION METHOD

Customer No.: 20350

Confirmation No.: 5740

Examiner: Hoa B. Trinh

Technology Center/Art Unit: 2814

AMENDMENT

Mail Stop Amendment

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed December 7, 2004, please enter the following amendments and remarks:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Amendments to the Drawings begin on page 7 of this paper and include both an attached replacement sheet and an annotated sheet showing changes.

Remarks/Arguments begin on page 8 of this paper.

An Appendix including amended drawing figures is attached following page 9 of this paper.